

Special Issue

Piezoelectric Materials, Devices and Integrated Systems

Message from the Guest Editors

All interested researchers are invited to contribute to this Special Issue with their original research articles, communications and review articles. Manuscripts will be internationally peer-reviewed. Please note that all submitted papers must be within the general scope of the Micromachines journal. Topics may include, but are not limited to, the following:

- Novel methods for the preparation of piezoelectric materials;
- Novel modelling and design methods of piezoelectric devices;
- Integrated circuit design for piezoelectric applications;
- Simulation and design methods of 3D-integrated systems;
- Promising applications of piezoelectric materials, devices, and integrated systems.

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Deadline for manuscript submissions

closed (30 January 2024)



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Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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manuscripts are peer-reviewed and a first decision is provided to authors approximately 16.8 days after submission; acceptance to publication is undertaken in 1.9 days (median values for papers published in this journal in the second half of 2025).